

# PROCEEDINGS OF SPIE

## ***Optical Design and Testing IX***

**Yongtian Wang**  
**Pablo Benítez**  
**Osamu Matoba**  
*Editors*

**21–22 October 2019**  
**Hangzhou, China**

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SPIE

**Volume 11185**

Proceedings of SPIE 0277-786X, V. 11185

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Optical Design and Testing IX, edited by Yongtian Wang, Pablo Benítez,  
Osamu Matoba, Proc. of SPIE Vol. 11185, 1118501 · © 2019 SPIE  
CCC code: 0277-786X/19/\$21 · doi: 10.1117/12.2560515

Proc. of SPIE Vol. 11185 1118501-1

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in *Optical Design and Testing IX*, edited by Yongtian Wang, Pablo Benítez, Osamu Matoba, Proceedings of SPIE Vol. 11185 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X  
ISSN: 1996-756X (electronic)

ISBN: 9781510630871  
ISBN: 9781510630888 (electronic)

Published by

**SPIE**

P.O. Box 10, Bellingham, Washington 98227-0010 USA  
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

[SPIE.org](http://SPIE.org)

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# Contents

vii	Authors
ix	Symposium Committees
xiii	Conference Committee

---

## SESSION 1      FREEFORM ILLUMINATION

---

11185 03	<b>Multi-channel freeform optics for glare-free lighting (Invited Paper)</b> [11185-2]
11185 04	<b>Generalized Monge-Ampère equations for illumination freeform design (Invited Paper)</b> [11185-3]
11185 05	<b>Heat flux simulation irradiation system design</b> [11185-4]

---

## SESSION 2      DIFFRACTIVE OPTICS AND HOLOGRAPHY

---

11185 08	<b>Novel liquid-crystal computer-generated hologram based on spatial light modulator interference exposure method</b> [11185-7]
----------	---

---

## SESSION 3      NOVEL IMAGING TECHNIQUES

---

11185 0B	<b>Tissue diagnosis using nanoscale morphological markers extracted from quantitative phase images (Invited Paper)</b> [11185-10]
11185 0F	<b>Sparse aperture imaging analysis for quasi four-mirror structure</b> [11185-14]

---

## SESSION 4      FREEFORM IMAGING

---

11185 0G	<b>Design of optical see-through head-mounted display systems using freeform optics (Invited Paper)</b> [11185-15]
----------	--

---

## SESSION 5      OPTICAL DESIGN AND TESTING

---

11185 0L	<b>Al mirrors in vacuum ultraviolet region</b> [11185-20]
----------	---

- 11185 ON **Design method for high magnification mid-wave infrared continuous zoom lens** [11185-22]
- 11185 OP **High-precision centering measurement of large-aperture aspheric mirror** [11185-24]
- 11185 OQ **Instantaneous wavefront measurement based on deflectometry** [11185-25]
- 11185 OR **Transient microscopic testing method based on deflectometry** [11185-26]

---

**POSTER SESSION**

---

- 11185 OS **Automatic detection device for defects of optic fiber imaging elements** [11185-27]
- 11185 OT **The optimization of optical system with liquid lenses via hybrid algorithm** [11185-28]
- 11185 OW **Liquid crystal hologram for cylinder lens measurement** [11185-31]
- 11185 OX **A method of real-time analysis for stray light uniformity of optical telescope** [11185-32]
- 11185 OY **Alignment of the wedge scanner prism utilizing second order split reflection** [11185-33]
- 11185 OZ **Optimization of the space-borne Infrared optical system by tolerance sensitivity analysis** [11185-34]
- 11185 10 **Core mismatching based in-fiber Michelson interferometer for liquid refractive index sensing** [11185-35]
- 11185 11 **Design of infrared optical system based on three germanium lens with low stray radiation** [11185-36]
- 11185 12 **Research on shape factor based on Gaussian radial basis function** [11185-37]
- 11185 14 **Global optimization to improve multi-configuration sensor** [11185-39]
- 11185 15 **Algorithm of design optics for illumination system with wide beam angle** [11185-40]
- 11185 16 **Photorealistic visualization of fluorescent materials with dual surface scattering** [11185-41]
- 11185 17 **Possibility of vergence disagreement reducing on the base of approximate restoration of the depth map** [11185-42]
- 11185 18 **Providing the quality control in manufacturing of optical elements** [11185-43]
- 11185 1A **Design of the illumination optical systems of the washing floodlight** [11185-45]

- 11185 1B **The theoretical research on fundamental mode 20/400- $\mu\text{m}$  fiber laser for beam propagation application** [11185-46]
- 11185 1C **Injection-seeded optical parametric oscillator at 1645 nm for space-borne remote sensing of  $\text{CH}_4$**  [11185-47]
- 11185 1D **An improved photovoltaic agriculture system with groove glass plate** [11185-48]
- 11185 1E **Inversion algorithm validation of 1.57- $\mu\text{m}$  airborne double-pulse IPDA lidar for atmospheric  $\text{CO}_2$  measurement** [11185-49]
- 11185 1G **Novel local variable magnification imaging optical system based on liquid lens** [11185-51]
- 11185 1H **Coaxial near-infrared illumination and imaging optical system design with common aperture** [11185-52]



## Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Bi, Decang, 1E  
Bogdanov, Nikolay, 15, 17  
Bykovskii, Sergei, 17  
Chang, Jun, 1G, 1H  
Chen, Baohua, 0F  
Chen, Bin, 0F  
Chen, Jiayi, 0P  
Chen, Weibiao, 1C, 1E  
Chen, Xiao, 1C  
Chen, Yixing, 0G  
Cui, Ze-yao, 11  
Dang, Xuan Du, 0N  
Desnijder, Karel, 03  
Ding, Zhanghao, 0G  
Fan, Junliu, 0F  
Fu, Yang, 0S  
Gao, Bin, 1A  
Gao, Yang, 12  
Geng, Dongxian, 1B  
Gu, Hanting, 0Q, 0R  
Han, Liang, 10  
Hanselaer, Peter, 03  
Hao, Qun, 0W  
Hoang, Minh Anh, 0N  
Hong, Jinsuk, 0Y, 0Z  
Hu, Yao, 08, 0W  
Huang, Yonggang, 0S  
Huang, Yusheng, 1B  
Huo, Tengfei, 0P  
Huo, Tonglin, 0L  
Ijzerman, W. L., 04  
Ingenhoff, Jan, 1D  
Jeong, Su Seong, 0Z  
Jiang, Shanping, 05, 08  
Jiao, Peng, 0S  
Jin, Chen-jie, 11  
Jin, Zheng, 0T  
Kajdacsy-Balla, Andre, 0B  
Kim, Sug-Whan, 0Y  
Kim, Youngsoo, 0Z  
Ko, Dai Ho, 0Z  
Koh, Hae Seog, 0Y  
Kong, Ming, 0Q, 0R  
Lee, Eung-shik, 0Z  
Lee, Kyoungmuk, 0Z  
Lemeshev, Andrew, 16  
Li, Bin, 0P  
Li, Jun Yang, 12  
Li, Mengjuan, 0P  
Li, Mingsuo, 14  
Li, Shiguang, 1C  
Li, Shuangying, 0L  
Li, Taoran, 0X  
Li, Wen Qiang, 12  
Li, Yejin, 0T  
Li, Zhengda, 0T  
Liang, Rongguang, 0Q, 0R  
Liu, Hua, 14  
Liu, Jiqiao, 1C, 1E  
Liu, Wen, 1D  
Liu, Yinggang, 10  
Long, You, 12  
Ma, Xiuhua, 1C  
Majeed, Hassaan, 0B  
Meuret, Youri, 03  
Ning, Xiaolong, 1D  
Pan, Zhi-feng, 11  
Popescu, Gabriel, 0B  
Potemin, Igor S., 15, 16, 17, 18  
Qiao, Xueguang, 10  
Qu, Hang, 1A  
Que, Dai Cuong, 0N  
Ren, Wei-feng, 11  
Ren, Yuan, 1G, 1H  
Romijn, L. B., 04  
Ryckaert, Wouter, 03  
Shao, Min, 10  
Shi, Pan, 0S  
Shin, Jung-Hwan, 0Y  
Sokolov, Vadim, 16  
Song, Dalin, 1G, 1H  
Song, Hongwei, 1G, 1H  
Sun, Haibin, 0T  
Sun, Haonan, 10  
Sun, Shengli, 0T  
Sun, Wenqing, 0F  
Takabayashi, Masanori, 0B  
ten Thije Boonkamp, J. H. M., 04  
Tian, Jianfeng, 0X  
Vu, Thanh Dat, 0N  
Wang, Cong, 0P  
Wang, Danyi, 05, 08  
Wang, Daodang, 0Q, 0R  
Wang, Fengli, 0L  
Wang, Haichao, 0P  
Wang, Jiuwang, 0S  
Wang, Shaopu, 05, 08, 0W  
Wang, Xuejiao, 1B

Wang, Yan, 18  
Wang, Yun, 0P  
Wang, Yun, 0S  
Wang, Zhanshan, 0L  
Wang, Zhen, 0W  
Wei, Hongjun, 0T  
Wei, Jinhong, 0T  
Wu, Quanying, 0F  
Wu, Rengmao, 0G  
Wu, Ying, 0X  
Xiao, Lei, 1A  
Xie, Zhongming, 0Q, 0R  
Yang, Linhua, 0S  
Yang, Xue, 0X  
Yang, Ye, 1G, 1H  
Yoon, Jeeyeon, 0Z  
Yu, Xin, 11  
Zhang, Haiping, 0F  
Zhang, Jun, 1A  
Zhang, Junxuan, 1C  
Zhang, Pengsong, 08  
Zhang, Wanlong, 0W  
Zhang, Wentao, 0Q, 0R  
Zhang, Xinyu, 1D  
Zhao, Guoliang, 1G, 1H  
Zhao, Qing, 1G, 1H  
Zhao, Ran, 0S  
Zhao, Yifei, 1G, 1H  
Zhdanov, Andrey, 15, 16, 17, 18  
Zhdanov, Dmitry, 15, 16, 17, 18  
Zheng, Jianan, 1D  
Zhou, Hongjun, 0L  
Zhou, Liang, 12  
Zhou, Liwei, 14  
Zhou, You, 0S  
Zhu, Ronggang, 14  
Zhu, Xiaojie, 1A  
Zhu, Xiaolei, 1C  
Zhu, Xiaopeng, 1E  
Zhu, Yadan, 1E  
Zhu, Yongli, 1A



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